

Resistivity Control of VO<sub>2</sub> Thin Film Stabilized by Li<sup>+</sup> Diffusion of LiCoO<sub>2</sub> LayerTohru HIGUCHI<sup>1,\*</sup>, Riku KANEKO<sup>1</sup> and Go NOTAKE<sup>1</sup> Department of Applied Physics, Tokyo University of Science, Tokyo 125-8585, Japan

## 1 Introduction

The metal-insulator transition (MIT) phenomena of VO<sub>2</sub> thin film can use as the resistive switching device by electric double layer transistor using ionic liquid [1]. However, the use of ionic liquids is not practical. To realize a more practical device, an all-solid-state redox element consisting of a Fe<sub>3</sub>O<sub>4</sub>/Li<sub>2</sub>O-SiO<sub>2</sub>-ZrO<sub>2</sub>/LiCoO<sub>2</sub>(LCO) multilayer structure film is realistic [2]. By using this device structure, it is possible to create neuromorphic devices and physical reservoir devices, and has the potential to become next-generation devices that can perform complex processing with low power consumption.

In this study, we prepared the VO<sub>2</sub>/LCO multilayer films on Al<sub>2</sub>O<sub>3</sub> (0001) substrate and examined their structural and electrical properties in order to explore the possibility of all-solid-state transistor using Li-ion conductor electrolyte and VO<sub>2</sub> thin films.

## 2 Experiment

Figure 1(a) show the device structure of LCO and VO<sub>2</sub> thin films. The LCO thin film was deposited on Al<sub>2</sub>O<sub>3</sub> (0001) substrate by RF magnetron sputtering. After forming a LiCoO<sub>2</sub> film on the left half of the substrate, a metal mask was attached and a VO<sub>2</sub> thin film was deposited on the right half using a V metal target and O<sub>2</sub> gas. The thin film section with a width of 1.5 mm where VO<sub>2</sub> and LCO overlap is a VO<sub>2</sub>/LCO multilayer structure. The substrate temperatures of these thin films were maintained at 700°C during deposition processes.

The crystal structures were confirmed using X-ray diffraction (XRD). The temperature dependence of the electrical resistance and ionic conductivity were measured using the DC two-terminal method and AC impedance method, respectively. The electronic structures of valence band and conduction band were characterized by photoemission spectroscopy (PES) and X-ray absorption spectroscopy (XAS), respectively, which are installed at the undulator beamline BL-2A in the PF at KEK in Japan.

## 3 Results and Discussion

Figure 1(b) shows the XRD patterns of the LCO (~100 nm), VO<sub>2</sub>/LCO and VO<sub>2</sub> (~120 nm) thin films as shown in Fig. 1(a). The LCO film exhibits a weak (003) peak at ~19.0°. The VO<sub>2</sub> film exhibits a single peak of (020) at ~40.0°. In the VO<sub>2</sub>/LiCoO<sub>2</sub> multilayer film, the presence of a LiCoO<sub>2</sub> was not confirmed, and only the (020) peak of VO<sub>2</sub> was observed.

Figure 2 shows the valence bands and conduction bands obtained from the PES and XAS spectra, respectively, of LCO, VO<sub>2</sub> and VO<sub>2</sub>/LCO thin films measured at 300K. The valence band and conduction band of LCO film is mainly composed of the Co 3d

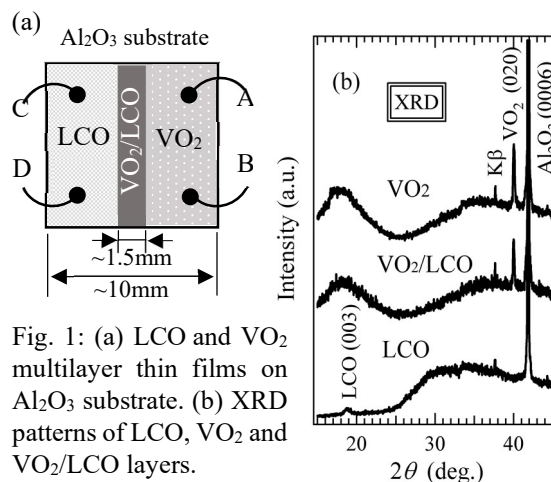


Fig. 1: (a) LCO and VO<sub>2</sub> multilayer thin films on Al<sub>2</sub>O<sub>3</sub> substrate. (b) XRD patterns of LCO, VO<sub>2</sub> and VO<sub>2</sub>/LCO layers.

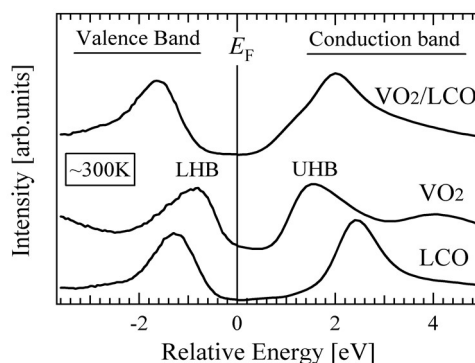


Fig. 2: Valence and conduction bands of LCO, VO<sub>2</sub> and VO<sub>2</sub>/LCO layers at ~300K.

hybridized with O 2p state. The VO<sub>2</sub> film at 300 K consists of the lower Hubbard band (LHB) and upper Hubbard band (UHB) of V 3d components. The energy separation between LHB and UHB reflects the electron correlation energy ( $U_{dd}$ ). The  $U_{dd}$  increases significantly in the VO<sub>2</sub>/LCO film. This suggests that the number of 3d electrons in the VO<sub>2</sub> film changes by the diffusion of Li ions, inducing strong electron correlation.

## References

- [1] M. Nakano et al, Nature **487** (2012) 459.  
[2] W. Namiki et al., ACS. Nano **14** (2020) 16065.

## Research Achievements

1. M. Takayanagi and T. Higuchi *et al.*, “Accelerated/decelerated dynamics of the electric double layer at hydrogen-terminated diamond/Li<sup>+</sup> solid electrolyte interface”. Materials Today Physics **31** (2023) 101006.

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